## **WEST Search History**

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DATE: Thursday, April 16, 2009

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	DB=P	GPB, USPT, USOC, EPAB, JPAB; PLUR=YES; OP=OR	
	L5	(substrate wafer semiconductor) and chamber and temperature adj (control\$3 regulat\$3 adjust\$3) and 34/\$.ccls.	219
	L4	(substrate wafer semiconductor) and chamber and temperature with (control\$3 regulat\$3 adjust\$3) and 34/\$.ccls.	498
	L3	(substrate wafer semiconductor) and chamber and temperature same (control\$3 regulat\$3 adjust\$3) and 34/\$.ccls.	601

END OF SEARCH HISTORY